DEMONSTRATION OF NIOBIUM TIN IN 218 MHZ LOW-BETA QUARTER WAVE ACCELERATOR CAVITY

Next generation SRF cavities for ion linacs

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ABSTRACT

A 218 MHz quarter wave niobium cavity has been fabricated for the purpose of demonstrating Nb3Sn technology on a low-beta accelerator cavity. Niobium-tin has been established as a promising next generation SRF material, but development has focused primarily in high-beta elliptical cell cavities. This material has a significantly higher TC than niobium, allowing for design of higher frequency quarter wave cavities (that are subsequently smaller) as well as for significantly lowered cooling requirements (possibly leading to cryocooler based de-signs). The fabrication, initial cold testing, and Nb3Sn coating are discussed as well as test plans and details of future applications.

INTRODUCTION

Motivation for Nb₃Sn in low-beta cavities

- Demonstrate next generation SRF cavity material in low-beta cavity
- Higher $T_{\rm c}$ reduces $R_{\rm BCS},$ which allows for both operation at higher frequency and lowered cryogenic power dissipation requirements
 - T_c of 18.3 K compared to 9.2 K for niobium
 - Reduces size of cavities and cryomodules
- Low power allows for operation on cryocooler no centralized helium cryoplant





BCS surface resistance vs temperatur plot (top left), accelerator cavity geometry regimes (bottom left), and example of physical scaling of cavity size vs frequency (right)

CAVITY DESIGN AND FABRICATION

- Design goal of ~200 MHz cavity with intention to run in ATLAS \rightarrow 218.25 MHz
- Aim to demonstrate 60 mT peak magnetic field, modest Vacc



- Cavity parts tabricated through hydroforming proces
 Local vendor Stuecklen Mfg.
- E-beam welding performed at Sciaky Inc





Cavity fabrication: niobium hydroformed parts (left, right), electron beam welding ports (middle) SURFACE PROCESSING AND CLEAN ASSEMBLY

- 120 um electropolish
- Standard SRF cleaning processes
 - Ultrasonic cleaning
 - High pressure rinsing
- Used SS helium vessel designed for ANL TC3
- Allowed for active pumping connection





Photos of cavity ultrasonic and high pressure rinsing fixturing (left) and of the stainless steel helium vessel used for testing in Argonne's TC3

COLD RF TESTING

- Multipacting barrier at V_{acc} < 10 kV
- E_{peak} = 49 MV/m, B_{peak} = 59.5 mT, limited by amplifier and coupling 218 MHz Q-curve at 4.5 K



COATING PROCESS



(4) Coating (3) Ramp (3) Ramp (2) Nucleation (2) Nucleation (3) Ramp (4) Coating (5) Anneal (3) Ramp (4) Coating (5) Anneal (1) Degas Photos of cavity being anodized before coating process (left) and with Sn heater assemblies (right). A typical coating process temperature profile (bottom).

Cavity surface post coating





*This material is based upon work supported by the U.S. Department of Energy, Office of Science, Office of Nuclear Physics, under contract number DE-AC02-06CH11357, and the Office of High Energy Physics, under contract number DE-AC02-76CH03000. This research used resources of ANL's ATLAS facility, which is a DOE Office of Science User Facility typetersen@anl.gov

